



2812
Docket No.: 2013P015

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

IL-YONG PARK, ET AL.

Application No.: 10/071,127

Filed: February 8, 2002

For: **method of fabricating power
semiconductor device having trench gate
structure**

Art Group: 2812

Examiner:

STATUS INQUIRY


Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

The above-captioned application, an amendment thereto, or an Appeal Brief was filed more than 18 months ago and no substantive Office Action has issued to date. Please provide the current status of the application and an indication of when the next Action is expected to issue.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: 9/8/03


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CERTIFICATE OF MAILING/TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Kelly Walsh

9-8-03
Date